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| PRIORITY Application Serial No. | 10/134,201 |
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| Inventor | |
| Assignee | Micron Technology, Inc. |
| PRIORITY Group Art Unit | 2812 |
| PRIORITY Examiner | J. Kennedy |
| Attorney's Docket No | Ml22-2464 |
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| Title: Methods for Forming Capacitor Structures; and Methods for Removal of Organic | |
| Materials | |

PRELIMINARY AMENDMENT

To:

Mail Stop Patent Application Commissioner for Patents

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AMENDMENTS